

OK TO ENTER: /JT/ (01/21/2009)

Docket No.: 1592-0163PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

Filed: March 22, 2007

Art Unit: 2895

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

RESPONSE TO FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 1, 2008, finally rejecting claims 1-5, please amend the above-identified U.S. patent application as follows:

Remarks/Arguments begin on page 2 of this paper.